ABSTRACT

A resist composition comprises: at least one type of a first compound having two or more intramolecular adamantyl structures represented by the chemical formula 1 below; a base resin; and a second compound which generates an acid by active beam irradiation.

[Chemical formula 1]

wherein X is $-(OCO)_{m-1}(CH_2)_{n-1}(COO)_{m-2}$, where m=0 or 1 and n=0,1,2 or 3 provided when n=0, m=0; and Y and Z are H, OH, F, Cl, Br, R or COOR, where Y may be Z, or Y and Z may be introduced in a single adamantyl structure and R represents a straight or branched alkyl group having 1 to 8 carbon atoms.